Se	arch No	oles

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/694,220	KIM ET AL.	
Examiner	Art Unit	
Tianjie Chen	2627	

	SEARCHED			
Class	Subclass	Date	Examiner	
369	300			
	221			
	13.13			
	44.19			
	44.23			
360	126			
310	309			
720	681	8/28/2006	TJ	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
:			

SEA (INCLUDING S	RCH NOTI	ES STRATEGY	)
		DATE	EXMR
East Report		8/28/2006	TJ